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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				Application Number	10/707,854-Conf. #1853
				Filing Date	January 16, 2004
				First Named Inventor	Janusz Murakowski
				Art Unit	N/A
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	00131-00281-US1

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear


FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>2</sup> -Number <sup>3</sup> -Kind Code <sup>4</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>5</sup>

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NON PATENT LITERATURE DOCUMENTS				
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CA		"Etchless Fabrication of Slab Photonic Crystals in Silicon", Janusz Murakowski et al., CLEO Conference Paper, May 19-25, 2002, Long Beach, California.		
CB		"Etchless Fabrication of Photonic Crystals in Silicon", Janusz Murakowski, et al., American Vacuum Society, J. Vac. Sci. Technology Bulletin 20(5), Sep/Oct 2002.		

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Examiner Signature		Date Considered	8/19/05
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